

1. (Twice Amended) An etch/strip apparatus integrated with cleaning equipment, comprising:

an etching line for etching and cleaning a substrate;

a stripping line for stripping the substrate, the stripping line being connected to the etching line;

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507 a cleaning line installed on the stripping line to clean and dry the substrate; and

an elevator for conveying the substrate from the stripping line to the cleaning line, wherein the etch/strip apparatus is a single piece of equipment.

6. (Twice Amended) An integrated etch/strip/clean apparatus, comprising:

an etching line for etching and cleaning a substrate;

a stripping line for stripping said substrate;

B2 a cleaning line integrated with said etching and stripping lines to clean and dry the substrate; and

an elevator to transfer said substrate from said stripping line to said cleaning line, wherein the etch/strip/clean apparatus is a single piece of equipment.